

CE

VERIFICATION
of conformity with
European Low Voltage Directive

No. S910010

Document holder: XYTRONIC INDUSTRIES LTD.
Type of equipment: Auto Temp 369
Type designation: 369

A sample of the equipment has been tested for CE-marking according to the Low Voltage Directive, 73/23/EEC, 93/68/EEC.

Standard(s) used for showing compliance with the essential requirements of the directive:

Standard(s):

EN 60335-1:94+A11:95+A1, A12:96+A13, A14:98+A2, A15:2000+A16:2001
EN 60335-2-45:1996

The referred test report(s) show that the product fulfills the requirements in the EMC Directive for CE marking. On this basis, together with the manufacturer's own documented production control, the manufacturer (or his European authorized representative) can in his CE Declaration of Conformity verify compliance with the EMC Directive.

Signed for and on behalf of
PEP Testing Laboratory



Date: FEB. 01, 2002

M. Y. Tsui

M. Y. Tsui / President

VERIFICATION

of conformity with
European EMC Directive

No. E910010

Document holder:

XYTRONIC INDUSTRIES LTD.

Type of equipment:

Temperature Controlled SMD Rework Tweezers,

Temperature Controlled Soldering Station

Type designation:

528, 369

A sample of the equipment has been tested for CE-marking according to the EMC Directive, 89/336/EEC.

Standard(s) used for showing compliance with the essential requirements of the directive:

EMC Standard(s):

Performance Criterion

EN 55014-1 : 1997

Class B

EN 61000-3-2 : 1995

+A1 : 1998+A2 : 1998

EN 61000-3-3 : 1995

EN 55014-2 : 1997

EN 61000-4-2 : 1995+A1 : 1998

B

EN 61000-4-4 : 1995

B

EN 61000-4-5 : 1995

B

EN 61000-4-6 : 1996

A

EN 61000-4-11 : 1994

C

The referred test report(s) show that the product fulfills the requirements in the EMC Directive for CE marking. On this basis, together with the manufacturer's own documented production control, the manufacturer (or his European authorized representative) can in his CE Declaration of Conformity verify compliance with the EMC Directive.

**Signed for and on behalf of
PEP Testing Laboratory**



M. Y. Tsui

Date: JAN. 29, 2002

M. Y. Tsui / President